



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date December 12, 2005

In re the Application of

Takeo KAGAMI et al.

Group Art Unit: 2653

Application No.: 10/600,444

Examiner: A. HEINZ

Filed: June 23, 2003

Docket No.: 116329

For: MAGNETO-RESISTIVE DEVICE WITH REDUCED SUSCEPTIBILITY TO ION BEAM
DAMAGE (AS AMENDED)

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 11, 2005, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 173978 in the amount of \$120 in payment for:

 X Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
 Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
 Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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12/13/2005 JADD01 00000029 10600444
JAO:KLK/tbh:1251 120.00 OP
03 FC:1201 600.00 OP
04 FC:1202 300.00 OP

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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
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